



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

OSHIMA, N. et al.

Atty. Ref.: 925-217; Confirmation No. 7939

Appl. No. 09/987,921

Group: 2828

Filed: November 16, 2001

Examiner: Vy, Hung

For: SEMICONDUCTOR LASER DEVICE CAPABLE OF SUPPRESSING LEAKAGE
CURRENT IN A LIGHT EMITTING END SURFACE AND METHOD FOR
MANUFACTURING SAME

* * * * *

October 1, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESPONSE AFTER FINAL

Responsive to the Official Action dated July 2, 2003, reconsideration is
respectfully requested for at least the following reasons.

10 #/Response

(10)

10/9/03

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